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PATENT
930055-2032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Keigo NAGAO, Tetsuro KUNISAWA, Tetsuo YAMADA
Serial No. : 10/538,137
For : METHOD OF PRODUCING IPEZOELECRIC THIN
FILM DEVICE AND PIEZOELECRIC THIN FILM
DEFINE
Filing Date : June 9, 2005
Examiner : Sharon Brooks
Group Art Unit : 2812
Confirmation No. : 1525

745 Fifth Avenue
New York, NY 10151

I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
addressed to: **Commissioner for Patents, P.O. Box 1450,**
Alexandria, VA 22313-1450, on May 8, 2006.

Ronald R. Santucci, Reg. No. 28,988

Name of Applicant, Assignee or Registered Representative

Signature

May 8, 2006

Date of Signature

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request the status of the above referenced patent application.

This application was filed on June 9, 2005 and to date no Official Action has yet issued. The last
communication regarding this application was the notice advising that assignment of the
application was recorded on June 9, 2005.

Respectfully submitted,
FROMMER LAWRENCE & HAUG LLP

By:

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